



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of: **NAKATA, Yoshihiro et al.**

Group Art Unit: 1771

Serial No.: **10/807,174**

Examiner: **Hai VO**

Filed: **March 24, 2004**

P.T.O. Confirmation No.: **4205**

**FOR: SILICON-BASED COMPOSITION, LOW DIELECTRIC CONSTANT FILM,
SEMICONDUCTOR DEVICE, AND METHOD FOR PRODUCING LOW
DIELECTRIC CONSTANT FILM**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 28, 2007

Sir:

In response to the Office Action dated **November 28, 2006**, extended to **March 28, 2007** by a **one** month Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page two of this paper.

Remarks/Arguments begin on page six of this paper.